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CLAIM AMENDMENTS

- 1. (Currently Amended) A system for automatically controlling the build-up of material on a substrate, comprising:
- a controllable semiconductor diode laser having a beam directed to a localized region of the substrate so as to form a melt pool thereon;
- a material feeder for feeding material into the melt pool to be melted by the beam to create a deposit having a physical attribute;
- an optoelectric sensor operative to output an electrical signal as a function of the physical attribute; and
- a feedback controller operative to automatically adjust the rate of material deposition as a function of the electric signal by modulating the laser to control the power of the beam.
 - 2. (Canceled)
- 3. (Currently Amended) The system of claim [[2]] 1, wherein the modulation of the laser is in the kilohertz range.
- 4. (Currently Amended) The system of claim [[2]] 1, wherein the modulation of the laser is up to 20 kHz.
- 5. (Previously Presented) A method of depositing material on a substrate, comprising the steps of:

heating the substrate with a high-power, rapid-response diode laser to create a melt pool in a laser interaction zone;

feeding material into the melt pool to create a deposit having a physical dimension; monitoring the laser interaction zone to generate an optical signal indicative of the physical dimension; and

controlling the deposition using the optical signal.

- 6. (Previously Presented) The method of claim 5, wherein the deposition is controlled by modulating the laser.
- 7. (Previously Presented) The method of claim 6, wherein the modulation of the laser is in the kilohertz range.
- 8. (Previously Presented) The method of claim 6, wherein the modulation of the laser is up to 20 kHz.